



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 2, 2024

IGI Report Number **LG667452813**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.80 X 5.97 X 3.91 MM**

GRADING RESULTS

Carat Weight **2.01 CARATS**

Color Grade **E**

Clarity Grade **SI 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

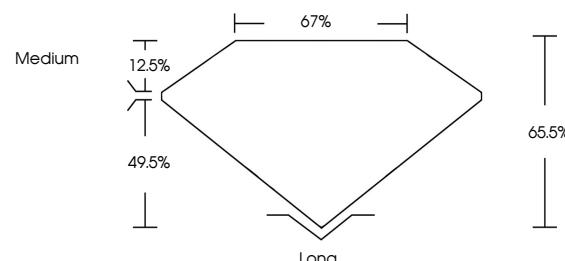
Fluorescence **NONE**

Inscription(s) **IGI LG667452813**

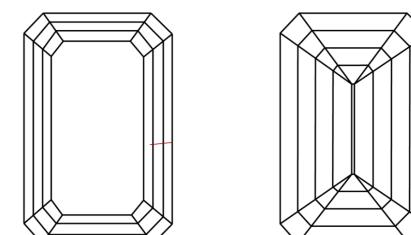
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG667452813
Report verification at igi.org

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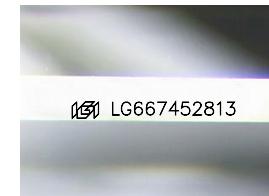
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GRADING RESULTS

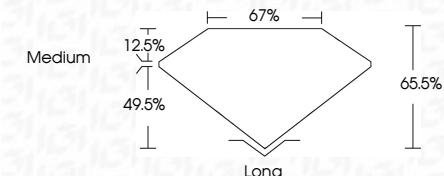
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Sample Image Used



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December 2, 2024	IGI Report No LG667452813	EMERALD CUT	E	SI 1	66.5%	67%	Medium	Long	EXCELLENT	NONE	IGI LG667452813
Carat Weight	2.01 CARATS										
Color Grade											
Clarity Grade											
Depth											
Table											
Grade											
Culet											
Polish											
Symmetry											
Fluorescence											
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